

## FINAL PRODUCT/PROCESS CHANGE NOTIFICATION # 16790DG

Generic Copy

Issue Date: 16-Jul-2014

<u>TITLE</u>: Final PCN for wafer fab transfer from Gifu to the waferfab United Microelectronics Corporation Taiwan (UMCT). (Group DG)

<u>PROPOSED FIRST SHIP DATE</u>: starting on 16-Oct-2014 (the actual ship date will be different by each product, please check the responsible Sales person).

AFFECTED CHANGE CATEGORY(S): Wafer Fabrication Location Change

### **FOR ANY QUESTIONS CONCERNING THIS NOTIFICATION:**

Contact your local ON Semiconductor Sales Office or Yasuhiro.lgarashi@onsemi.com

**SAMPLES**: Contact your local ON Semiconductor Sales Office or <a href="mailto:Shigehito.Matsumoto@onsemi.com">Shigehito.Matsumoto@onsemi.com</a>

#### **ADDITIONAL RELIABILITY DATA:** May be available

Contact your local ON Semiconductor Sales Office or Kazutoshi.Kitazume@onsemi.com

#### **NOTIFICATION TYPE:**

Final Product/Process Change Notification (FPCN)

Final change notification sent to customers. FPCNs are issued at least 90 days prior to implementation of the change.

ON Semiconductor will consider this change approved unless specific conditions of acceptance are provided in writing within 30 days of receipt of this notice. To do so, contact <quality@onsemi.com>

### **DESCRIPTION AND PURPOSE:**

This is a Final Process Change Notification to announce the transfer of products from Sanyo wafer fabrication sites located in Gifu to the wafer fabrication United Microelectronics Corporation Taiwan (UMCT).

The product design and electrical specifications will remain identical. A full electrical characterization over the temperature range will be performed for each product to check the device functionality and electrical specifications. Qualification tests are designed to show that the reliability of transferred devices will continue to meet or exceed ON Semiconductor standards.

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## **RELIABILITY DATA SUMMARY**

# **Group DG**

Conditions:	Interval:	Results
Ta=150degC	1000 hrs	Pass
Ta=-55degC	1000 hrs	Pass
Ta=85degC, RH=85%	1000 hrs	Pass
Tj=150degC	1000 hrs	Pass
Ta=150degC,VDSS=max	1000 hrs	Pass
Ta=-55degC to 150degC 30min each	100 cycles	Pass
Ta=121degC,2.03×10⁵Pa,100%	50 hrs	Pass
ow) Solder Temp.:260degC±5degC	10s	Pass
Solder Temp.: 245degC ± 5degC	5 s	Pass
-	Ta=150degC Ta=-55degC Ta=85degC, RH=85% Tj=150degC Ta=150degC,VDSS=max Ta=-55degC to 150degC 30min each Ta=121degC,2.03×10 <sup>5</sup> Pa,100% bw) Solder Temp.:260degC±5degC	Ta=150degC       1000 hrs         Ta=-55degC       1000 hrs         Ta=85degC, RH=85%       1000 hrs         Tj=150degC       1000 hrs         Ta=150degC,VDSS=max       1000 hrs         Ta=-55degC to 150degC 30min each       100 cycles         Ta=121degC,2.03×10 <sup>5</sup> Pa,100%       50 hrs         ow) Solder Temp.:260degC±5degC       10s

# **ELECTRICAL CHARACTERISTIC SUMMARY**

No change to the device data sheets is being made. All parametric performance and limits remain the same.

## **CHANGED PART IDENTIFICATION**

No change to current part making will occur. Making traceability codes will be able to identify wafer fab die source.

# <u>List of General affected parts</u>: Group DG

PART\_ID EFC4618R-TR

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